



**NC STATE**

# **NANOFABRICATION FACILITY**

**Grand Re-Opening**

**January 8, 2018 | 3:00pm**

**Monteith Research Center, Room 136**

**Refreshments to be served**

Please RSVP to Dr. Phil Barletta: [pbarlet@ncsu.edu](mailto:pbarlet@ncsu.edu)

**[nnf.ncsu.edu](http://nnf.ncsu.edu)**



# Welcome to the “New” NNF

January 8, 2018

Dr. Phil Barletta  
NNF Director of Operations

[pbarlet@ncsu.edu](mailto:pbarlet@ncsu.edu)

3-1976

# NNF Strategic Plan

- **Goal 1: Proactive approach to safety**
  - Instill a safety-first mindset in the staff and users
  - Collaborate with health and safety personnel at the University level
- **Goal 2: Exceptional technical performance**
  - Talented and dedicated staff
  - Emphasis on equipment uptime
  - Constantly looking to expand capabilities
- **Goal 3: Growing customer base**
  - Retention of current customers by consistent performance
  - Active recruitment of new users
- **Goal 4: Engagement with the local community**
  - Including NCSU, other universities, and local companies
  - More than just a business relationship

# Dr. Philip Barletta, NNF Director of Operations



- Ph.D., Materials Science (2006)
  - North Carolina State University
  - Studied under Dr. Salah Bedair
- M.S., Materials Science (1999)
  - North Carolina State University
  - Studied under Dr. Jerry Cuomo
- B.S., Materials Science (1996)
  - Wilkes University

## Work Experience

- Program Manager, Micross AIT (2016-2017)
- Research Engineer/Engineering Manager, RTI International (2006-2016)
- Senior Scientist, Dot Metrics Technologies (2005-2006)
- Process Engineer, Litespec Optical Fiber (1999-2000)

# New NNF Staff

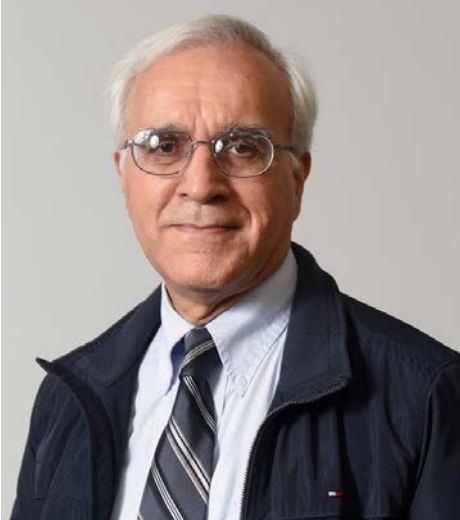


- Greg Allion, our new lithography engineer, started 8/14
- Was recruited from the University of Michigan, where he had 15 years of experience with optical and e-beam lithography
- Also has significant wafer bonding experience
- Experience in processing development consulting for local startups



- Jim Mitchell is the newest member of our team, having started 9/11
- Specializes in semiconductor equipment repairs
- Was recruited from Cree, and has 34 years experience working on all semiconductor equipment, primarily lithography tools

# NNF Veterans (1)



- Marcio Cerullo is our Laboratory Manager
- Started at NNF in 2006
- Fourteen years experience at AT&T Bell Laboratories
- Also worked at Tompkins Research Corp and Tyco Electronics
- B.S., M.S. University of Sao Paulo, Brazil



- Nicole Hedges is our Business and Education Manager
- Started at NNF in 2009
- Four years experience at GE Global Research Center
  - Worked extensively with MEMS and microfluidics
- B.S. Georgia Tech, M. Engr. U. of Michigan



## NNF Veterans (2)



- Jeff Ricker-Hagler is our Hardware Engineer
- Started at NNF in 2016
- Ten years with GE as Nuclear Reactor Inspector
- Also worked with Wolfspeed and The Nonwovens Institute at NCSU
- AAS Nuclear Technology



- Sharon Guidry is our Accounting Technician
- Started at NNF in 2014
- Experience as Executive Assistant and Business Consultant with Nationwide Insurance
- Educational background from Wake Tech Community College

# Undergraduate hires



Andrew Squires



Anne Corbett



Zach Ledford

- NNF will have three undergraduate students helping out in the Spring 2018 semester
- Welcome Andrew, Anne, and Zach!



# Recent Improvements to NNF (1)

- Recognition as a University Core Facility

- Interaction with the Office of Research, Innovation, and Economic Development (ORIED)
- Regularly scheduled meetings with Assistant Vice Chancellor Jon Horowitz
- NNF gets significant support, but also more scrutiny

- Increased staffing

- Three new hires in the last four months
- Six total technical staff, plus part-time accounting technician and one temporary employee (through January 31)
- Three undergrad student hires for Spring 2018 semester

- Investment in infrastructure

- Air handler upgrade (\$6.4 mil) – second floor completed November 2017
- Thermals loop (\$3-4 mil)

- Emphasis on upgrading documentation procedures

- SOPs, maintenance logbooks, PM schedules, equipment tracking

# Recent Improvements to NNF (2)

- \$1 mil+ investment in new instrument capabilities



Atomic Layer  
Deposition  
(ALD)



III-V plasma  
etcher



Direct-write  
laser  
lithography



Rapid Thermal Processor

# Particle measurement

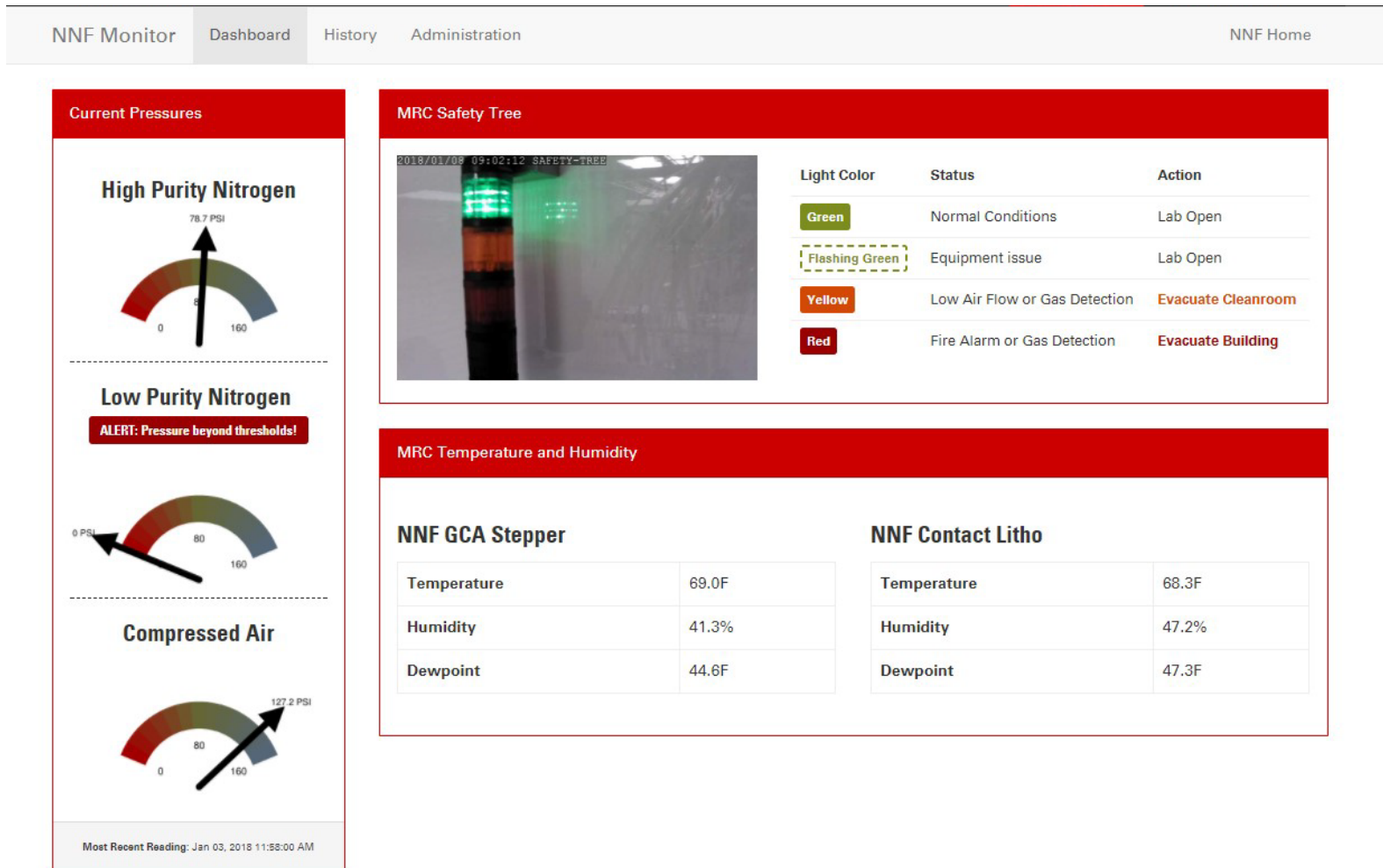
- Lasair III Particle Measurement Instrument purchased to verify lab cleanliness
- Measurements will be logged every month
- December 2017 measurements verify that we have a Class 100 (ISO 5) cleanroom



Heidelberg room				
	N/m <sup>3</sup>	N/m <sup>3</sup>	N/m <sup>3</sup>	N/m <sup>3</sup>
≥0.1 µm	2896	10560	3532	<b>5663</b>
≥0.2 µm	1695	3037	1907	<b>2213</b>
≥0.3 µm	1130	1201	1413	<b>1248</b>
≥0.5 µm	600	424	494	<b>506</b>
≥1 µm	247	141	247	<b>212</b>
≥5 µm	0	0	35	<b>12</b>

Class 1	Class 10	Class 100	Class 1000
N/m <sup>3</sup>	N/m <sup>3</sup>	N/m <sup>3</sup>	N/m <sup>3</sup>
1000	10,000	100,000	1,000,000
237	2370	23,700	237,000
102	1020	10,200	102,000
35	352	3,520	35,200
8	83	832	8320
--	--	29	293

# Temperature/humidity monitoring



- Current status of cleanroom conditions can be found at [www.nnf.ncsu.edu/monitor](http://www.nnf.ncsu.edu/monitor)

# NNF contributions to NCSU community (and beyond)

- NNF supported 107 individual users in 2016-2017
  - 92 NCSU
  - 15 external
- These users worked a total of 8422 hours across 93 projects
- NNF contributed to **\$4.9 million** worth of funded projects for NCSU investigators
- With your help, we can push these numbers even higher in 2017-2018
  - We will also start tracking publications written that contain NNF work

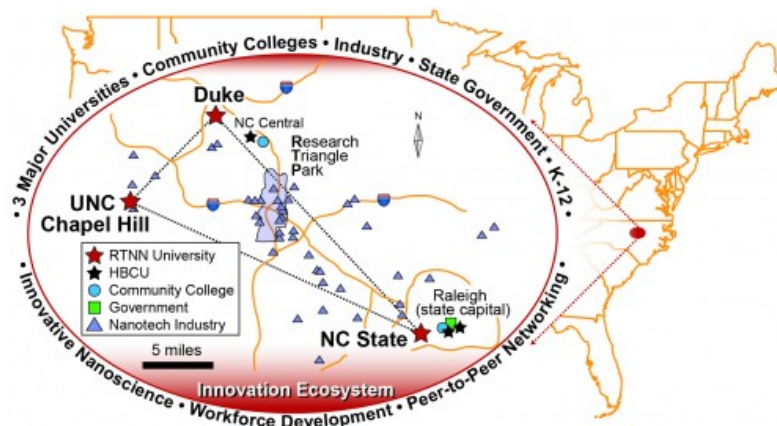
# Cleanroom courses

- ECE 442, ECE 739, and MSE 335 will continue to be offered in NNF
- Starting in Fall 2018, ECE 442 and ECE 739 will move out of the main cleanroom (MRC 240) into MRC 106
- However, the Spring 2018 offering will still be held in the main cleanroom
  - NNF staff will be teaching lab
  - Lab sessions will be held Thursday afternoon and all day Friday
- Please respect the staff's time when they are engaged in a teaching activity for the course



# NNF participation in RTNN

- NNF, along with AIF (NCSU), SMIF (Duke), and CHANL (UNC), is part of the Research Triangle Nanotechnology Network (RTNN)
- RTNN is one of sixteen NSF-funded National Nanotechnology Coordinated Infrastructure (NNCI) sites
- The role of the RTNN is to enhancing access to university resources by overcoming common barriers
  - Awareness
  - Cost
  - Distance



# Next six months

- Removal of UHV MOCVD tool
  - Will open up space in the lab
  - Big thanks to Dr. Bill Kiether for leading this task
- Increased capabilities
  - Image reversal oven, spin-coating track system, hot piranha bath, spin-on glass
- Revisit the Equipment Sharing Programs
  - Many faculty have generously donated equipment to NNF over the last several years
  - Protocol for how to handle such “faculty-owned” tools in shared facility needs to be formalized
  - Dr. Barletta will be reaching out to faculty for discussion and input
- NNF staff to attend individual PI research group meetings
  - Please speak up if you would like us to join a group meeting of yours!

# After-hours work policy

- NNF hours will be 8am – 8pm Monday-Friday
  - At least one NNF staff member will be present during those hours
  - All standard processes are available to users
- Weekend work in NNF will be allowed if and only if all of the following conditions are met:
  - Users are NCSU students or employees
  - At least two NNF-certified users are present at all times; i.e. “the buddy system”
  - The user, the buddy, and the work to be done ***has been approved, in advance, by Dr. Barletta***
  - No acids or hazardous/flammable gasses are to be used
- Additional critical need situations will be handled on a case-by-case basis
  - Please coordinate in advance with Dr. Barletta

# User meeting schedules

- We will have user meetings twice a year
  - These correspond with the spring and fall maintenance shutdowns
    - Spring meeting: April 9, 2018
    - Fall meeting: October 8, 2018
  - User meeting will include the following:
    - Update from Dr. Barletta on lab operation
    - Presentation from EHS on a given safety topic
    - Student technical presentation
- Fall meeting will also be accompanied by lab cleanup
  - All users are expected to contribute!
  - Fall lab cleanup will be October 10, 2018

# New NNF Webpage



[NNF Home](#) [Get Started](#) [Monitor](#) [Capabilities](#) [Safety](#) [Contact NNF](#)



## Welcome!

The NCSU Nanofabrication Facility provides users with a broad range of nanofabrication capabilities to support a diverse set of projects.

The facility houses virtually all standard thin film processing tools. The facility serves as a melting pot for a community of top-notch researchers from academia, government labs and industry representing a variety of disciplines.

The vast majority of users prefer to come on-site for hands-on access to the facility. Users with well-defined projects can also have their work performed by our experienced staff.

[Get Started](#)

[EUTS Login](#)

- Updated NNF webpage located at **[nnf.ncsu.edu](http://nnf.ncsu.edu)**
- Same functionality as old webpage, with more user friendly design
- EUTS will continue to be used for logging in and billing until Mendix comes online for NNF (Summer/fall 2018)

# NNF Twitter Page



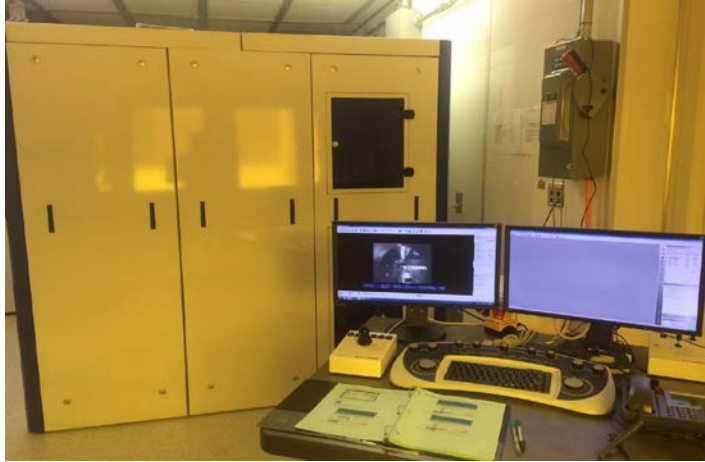
twitter   
@NCStateNanoFab

- Will be used as a communication tool for NNF and its users
  - Report NNF equipment/lab news
  - Highlight work done in NNF
  - Advertise success stories from NCSU PIs
  - Promote seminars, short courses
  - RTNN news
  - Share any “cool” photos/videos of our work at NNF!



# Under-utilized NNF tools

## Raith 150 Two E-beam Lithography



- Feature sizes down to 20nm
- Specially designed sample holders: Pieces – 6” Wafers; rotate/tilt chuck
- Low kV exposure and imaging (SE detector with BSE detector option)
- Accelerating voltage up to 30kV
- Stitching and overlay accuracy of about 35nm

- High-throughput patterning of nanostructures
- Up to 2” diameter imprint area
- Variable time, temperature, pressure
  - $T_{\max} = 250^{\circ}\text{C}$ ,  $P_{\max} = 70 \text{ bar}$
- Low cost, relatively simple alternative to optical and/or e-beam lithography

## Nanoimprint Lithography



# NNF Big Questions

## Short/mid term

- What capabilities are we most sorely missing?
- Where are the gaps in staff expertise?
- What is the best way to reach local small companies?
- What sets us apart from competing facilities?
- What sources of funding are available to us?
- How do we handle high-dollar service contracts?

## Long term

- Do we want to become a 24/7 operation?
- How can we expand our physical footprint?
- What do we envision for the NNF in five years? Ten years? Beyond that?

# NNF Wish List

- Dicing saw
- Wafer bonder
- Filmetrics measurement tool
- RF sputter deposition
- Upgraded  $\text{Si}_3\text{N}_4$  growth tool



## Gentle Reminder

When publishing or presenting work that was supported by the NNF tools and/or staff, please be sure to acknowledge us:

This work was performed in part at the NCSU Nanofabrication Facility (NNF), a member of the North Carolina Research Triangle Nanotechnology Network (RTNN), which is supported by the National Science Foundation (Grant ECCS-1542015) as part of the National Nanotechnology Coordinated Infrastructure (NNCI).

This acknowledgement statement can be found on the NNF website:

**[nnf.ncsu.edu](http://nnf.ncsu.edu)**

Thank you!